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Docket Number (Optional)

Application Number

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10/712,567

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Applicant

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Filing Date

11/13/03

Group Art Unit

2822

(Use several sheets if necessary)

U. S. Patent Documents

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
LL	AL	11-272238	10/08/99	Japan	G09G	3/36		X
LL	AM	2002-0037282	05/18/02	Korea	G02F	1/133		X
	AN							
	AO							
	AP							
	AQ							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

EXAMINER

/Lun Lao/

DATE CONSIDERED

06/20/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.